RESPONSE UNDER 37 C.F.R. § 1.116 EXPEDITING PROCEDURE EXAMINING GROUP 2800

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Applicant:

Pai, et al.

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Examiner:

Le, Thao X.

For:

Dual Poly Layer and Method of Manufacture

Mail Stop: After Final Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

## **RESPONSE UNDER 37 CFR § 1.116**

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06/27/05

Dear Sir:

Applicants respectfully submit the following amendments and remarks in response to Examiner's Office Action dated April 20, 2005, which Action is made Final. Applicants respectfully request that these amendments and remarks be entered in pursuant to the provisions of 37 CFR § 1.116, and respectfully request reconsideration of Claims 24-33.